

December 19, 2003

To: Commissioner for Patents

P.O.Box 1450

Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572

28 Davis Avenue

Poughkeepsie, N.Y. 12603

Subject:

Serial No. 10/666,493 09/19/03

Kuo-Tang Hsu et al.

A NOVEL DESIGN TO ELIMINATE WAFER STICKING

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation In An Application.

The following Patents and/or Publications are submitted to comply with the duty of disclosure under CFR 1.97-1.99 and 37 CFR 1.56.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 2, 2003.

Stephen B. Ackerman, Reg.# 37761

Signature/Date

15/25/03

TSMC-02-1129

- U.S. Patent 6,520,839 to Gonzalez-Martin et al., "Load and Unload Station for Semiconductor Wafers, " describes an apparatus for semiconductor manufacturing.
- U.S. Patent 6,407,009 to You et al., "Methods of Manufacture of Uniform Spin-On Films, " discloses methods to spin-on films for integrated circuits.
- U.S. Patent 6,267,853 to Dordi et al., "Electro-Chemical Deposition System, " describes an electrochemical deposition system for integrated circuit manufacturing.

The following two U.S. Patents disclose a manufacturing tool for integrated circuit processing:

- 1) U.S. Patent 5,950,327 to Peterson et al., "Methods and Apparatus for Cleaning and Drying Wafers."
- 2) U.S. Patent 5,899,216 to Goudie et al., "Apparatus for Rinsing Wafers in the Context of a Combined Cleaning Rinsing and Drying System."

Sincerely,

Stephen B. Ackerman,

INFO	INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Usis several shouls if nocossary)									TSMC-02-1129 10/666, 493 Applicant Kuo-Tang Hsu et al. [Fling Date - 2/12/ Group AT UNT					
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.